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(Use as many sheets as necessary)

Sheet 1

of 1

**Complete if Known**

Application Number	10/706,586
Filing Date	11/12/2003
First Named Inventor	John Brian Pendry
Art Unit	2821
Examiner Name	
Attorney Docket Number	8068

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
TP		Bessel Functions - Orders 3-9, Bessel Functions of Integer Order, Compiled from British Association for the Advancement of Science, Bessel functions, Part II. Functions of positive integer order, Mathematical Tables, vol. X (Cambridge Univ. Press, Cambridge, England, 1952) and Mathematical Tables Project, Table of $f_n(s) = n!(1/2X)^{-n} J_n(x)$ . J. Math. Phys. 23, 45-60 (1944) (with permission).	
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Examiner  
SignatureDate  
Considered

21 25/05

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